

L Number	Hits	Search Text	DB	Time stamp
-	892	dielectric adj barrier adj discharge	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/12/16 13:25
-	87	((dielectric adj barrier adj discharge) and ((substrate wafer specimen sample) with (mov\$3 transport\$3 slid\$3 position\$3 progress\$3)))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/12/16 10:23
-	56	((dielectric adj barrier adj discharge) and ((substrate wafer specimen sample) with (mov\$3 transport\$3 slid\$3 position\$3 progress\$3))) and length	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/12/16 10:05
-	9	((dielectric adj barrier adj discharge) and ((substrate wafer specimen sample) with (mov\$3 transport\$3 slid\$3 position\$3 progress\$3))) and ((overlap\$4 cross\$3 overlay\$3 overlie overlying coincid\$3) with area)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/12/16 10:25
-	7	((dielectric adj barrier adj discharge) and ((substrate wafer specimen sample) with (mov\$3 transport\$3 slid\$3 position\$3 progress\$3))) and ((overlap\$4 cross\$3 overlay\$3 overlie overlying coincid\$3) with area)) and (screen\$3 filter\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/12/16 10:26
-	2115	dielectric adj barrier adj discharge) (excimer near lamp	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/12/16 10:23
-	691	((dielectric adj barrier adj discharge) (excimer near lamp) and ((substrate wafer specimen sample) with (mov\$3 transport\$3 slid\$3 position\$3 progress\$3)))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/12/16 10:23
-	65	((dielectric adj barrier adj discharge) (excimer near lamp) and ((substrate wafer specimen sample) with (mov\$3 transport\$3 slid\$3 position\$3 progress\$3))) and (250/453.11,454.11,455.11,492.1,492.2.ccls. 427/582.ccls. 313/507.ccls. 315/\$.ccls.)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/12/16 10:25
-	15	((dielectric adj barrier adj discharge) (excimer near lamp) and ((substrate wafer specimen sample) with (mov\$3 transport\$3 slid\$3 position\$3 progress\$3))) and (250/453.11,454.11,455.11,492.1,492.2.ccls. 427/582.ccls. 313/507.ccls. 315/\$.ccls.) and ((overlap\$4 cross\$3 overlay\$3 overlie overlying coincid\$3) with area)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/12/16 10:25
-	13	((dielectric adj barrier adj discharge) (excimer near lamp) and ((substrate wafer specimen sample) with (mov\$3 transport\$3 slid\$3 position\$3 progress\$3))) and (250/453.11,454.11,455.11,492.1,492.2.ccls. 427/582.ccls. 313/507.ccls. 315/\$.ccls.) and ((overlap\$4 cross\$3 overlay\$3 overlie overlying coincid\$3) with area)) and (screen\$3 filter\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/12/16 10:26
-	12	("5015331" "5198724" "5369336" "5414324" "5415719" "5510158" "5698039" "5763892" "5800618" "5882424" "5895558" "5900103" "2001/0022499").PN.	USPAT	2003/12/16 11:04
-	12	("5015331" "5198724" "5369336" "5414324" "5415719" "5510158" "5698039" "5763892" "5800618" "5882424" "5895558" "5900103" "2001/0022499").PN.	USPAT	2003/12/16 11:19
-	0	6664737.URPN.	USPAT	2003/12/16 11:21
-	2	4837484.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/12/16 11:31
-	7	((dielectric adj barrier adj discharge) and 250/492.1.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/12/16 13:29

-	2	(dielectric adj barrier adj discharge) and 427/582.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/12/16 13:30
-	1	Fujitugu-Hideki\$.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/12/16 13:40
-	199	(Ushiodenki adj Kabushiki adj Kaisha).as.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/12/16 13:40
-	32	((Ushiodenki adj Kabushiki adj Kaisha).as.) and (dielectric adj barrier adj discharge)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/12/16 13:45